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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Hideki MATSUMURA, et al.**

Group Art Unit: **2818**

Serial No.: **10/041,609**

Examiner: **BERRY, Renee R.**

Filed: **January 10, 2002**

Confirmation No.: **5375**

For: **METHOD AND APPARATUS FOR DEPOSITING A THIN FILM, AND SEMICONDUCTOR DEVICE HAVING SEMICONDUCTOR-INSULATOR JUNCTION**

Attorney Docket No.: **971003B**

Customer Number: **38834**

**SUBMISSION OF FORMAL DRAWINGS**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

February 11, 2004

Sir:

Applicants submits herewith 5 sheets of formal drawings for the above-identified application.

Applicant respectfully request that the formal drawings submitted herewith be approved by the Examiner.

If any fees are required in connection with this submission, please charge our Deposit Account No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

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